

300 mm Manufacturing Workshop

In conjunction with 1999 International Symposium on Semiconductor Manufacturing, a half-day “300 mm Manufacturing Workshop” was organized on Sunday October 10, 1999 at Santa Clara Marriot, Santa Clara, California. The IEEE EDS technical committees of Semiconductor Manufacturing and VLSI Technology and Circuits organized the workshop jointly. The workshop consisted of 13 invited talks followed by the panel discussion. About 150 persons attended the workshop. A workbook consisting of the collection of the written material provided by the speakers and panel-discussion members was distributed to the workshop attendees. Rajendra Singh of Clemson University, John Lowell of Oracle Corporation and Kamal Rajkanan of KLA-Tencor Corporation organized the workshop.



Workshop organizers, invited speakers and panel members